

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of :
Masamichi NAKASHIBA et al. : Docket No. 2000-0722
Serial No. 09/589,388 : Group Art Unit 3723
Filed June 8, 2000
APPARATUS FOR AND METHOD FOR
POLISHING WORKPIECE



THE COMMISSIONER IS AUTHORIZED
TO CHARGE ANY DEFICIENCY IN THE
FEE FOR THIS PAPER TO DEPOSIT
ACCOUNT NO. 23-0975.

TECHNOLOGY CENTER 3700

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AMENDMENT IN REISSUE

Assistant Commissioner for Patents,
Washington, D.C.

Sir:

Prior to initial examination of the above-referenced reissue
application, kindly amend the application as follows:

IN THE CLAIMS:

Please add the following new claims:

Sub F3 18
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~~38. A method of polishing a surface of a workpiece, the
method comprising:
 holding a workpiece with a top ring;
 applying a first polishing pressure to a central portion
of the workpiece;
 applying a second polishing pressure to an outer
circumferential portion of the workpiece, wherein the first
polishing pressure is different than the second polishing pressure,
and the first and second polishing pressures are independently
adjustable; and
 pressing a presser ring against a polishing surface.~~

10/12/2000 SSITHIB1 00000004 09589388

01 FC:103
02 FC:102

270.00 OP
640.00 OP

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